IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: PARKHE ET AL

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2-16-08 -MKNOMN--08/2020-20-20

Filed:

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CHEMICAL VAPOR DEPOSITIONS

For: CHEMICAL VAPOR DEPOSITION OF BARRIERS FROM NOVEL PRECURSORS Group Art Unit: Unknown

09/505638 02/16/00

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited on 2/16/200, 2000, with the U. S. Postal Service as First Class Máli in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

2/16/2000 Sech Mulesky

INFORMATION DISCLOSURE STATEMENT

The applicants, and the attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 C.F.R. 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 C.F.R. > 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined in 37 C.F.R. > 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449

MA 438-1-27-27-26

Respectfully submitted

Robert M. Mulcahy Registration No. 25,436

APPLIED MATERIALS, INC. P. O. Box 450A

Santa Clara, California 95052 Attorney for Applicant

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U.S. Department of Commerce, Patent and Trademark Office						No.	Serial No.		
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LIST OF RELEVANT ART CITED BY APPLICANT					Applicar	Applicant			
(Use several sheets if necessary)						PARKHE ET AL.			
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Initial	ـــــ	Number	Date	Name	Class	Subclass	Appropriat	te	
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OTHER ART (Includin	g Author, Title,	, Date, Pertinent	Pages, Etc.)					
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*EXAMINER:	Initial	if reference cons	idered, whether	or not citation is in confo	ormance with N	1PEP 609; Draw	line through	citation if	

not in conformance and not considered. Include copy of this form with your communication to applicant.